



1746

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Application of

Applicants : Sandhu et al.
Serial No. : 09/998,073
Filed : November 30, 2001
Title : METHOD AND SYSTEM PROVIDING HIGH FLUX OF POINT OF USE
ACTIVATED REACTIVE SPECIES FOR SEMICONDUCTOR PROCESSING
Docket No. : MIO 0084 PA
Art Unit : 1746
Examiner : Gentle E. Winter

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CERTIFICATE OF MAILING
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#5
4-9-03

OFFICIAL DRAFTSPERSON
Assistant Commissioner for Patents
Washington, D. C. 20231

Sir or Madam:

TRANSMITTAL OF FORMAL DRAWINGS

Enclosed herewith are formal drawings for the above-identified patent application.

Respectfully submitted,

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& SCHAEFF, L.L.P.

By

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